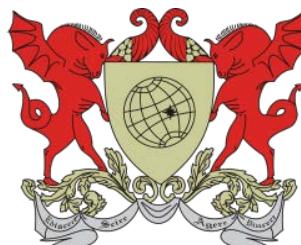


“Interface fluctuations and KPZ universality class – unifying mathematical, theoretical, and experimental approaches”

KPZ Universality and Anomalous Scaling in the Growth of CdTe Thin films



UNIVERSIDADE
FEDERAL DE VIÇOSA

Universidade Federal de Viçosa, Mg, Brazil



Outline

- Why are two-dimensional KPZ experimental confirmations rare?
- The first robust 2D-KPZ growth found: CdTe films grown on Si(001) in “MBE environment” at 250°C. What can be learned from it?
- **Changing the deposition temperature** in this 2D-KPZ system: “Anomalous-to-Normal Scaling”, Inversion in the λ 's signal, crossover effects and so forth.
- Conclusions and Perspectives.

2D-KPZ Growth: Why are they experimentally rare?

- **Inexorable** experimental obstacles: Difficult to image 2D-growth, poor statistics, finite-time growth, etc.
- Specific obstacles depending on what system is considered:
 - * Morphological instabilities  Below ζ , there is no critical situation.
It breaks the scaling invariance.

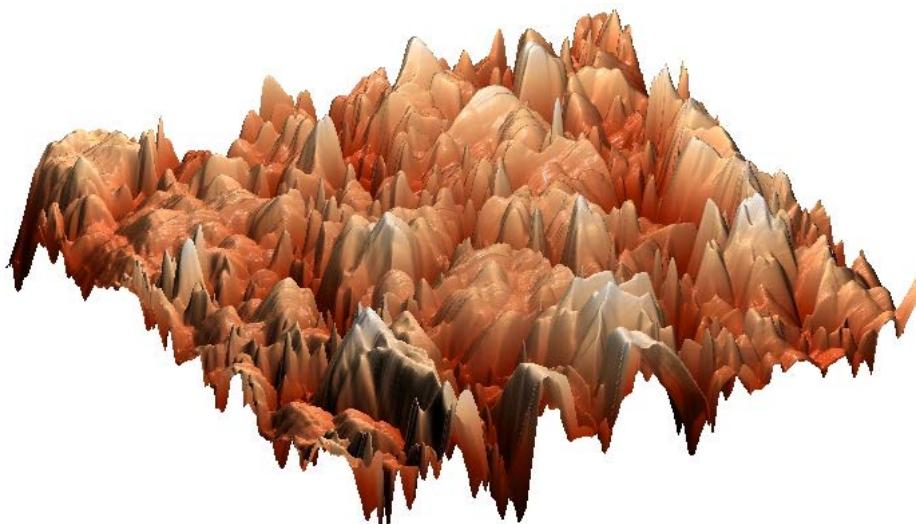


Fig. Example of a surface containing morph. inst. AFM image for a CdTe film grown on Si(001) by HWE, at $T = 300^\circ\text{C}$

Morphological instabilities at the surface

Unfortunately, below ζ , local roughness, and HHCF, also behave as a power-law...

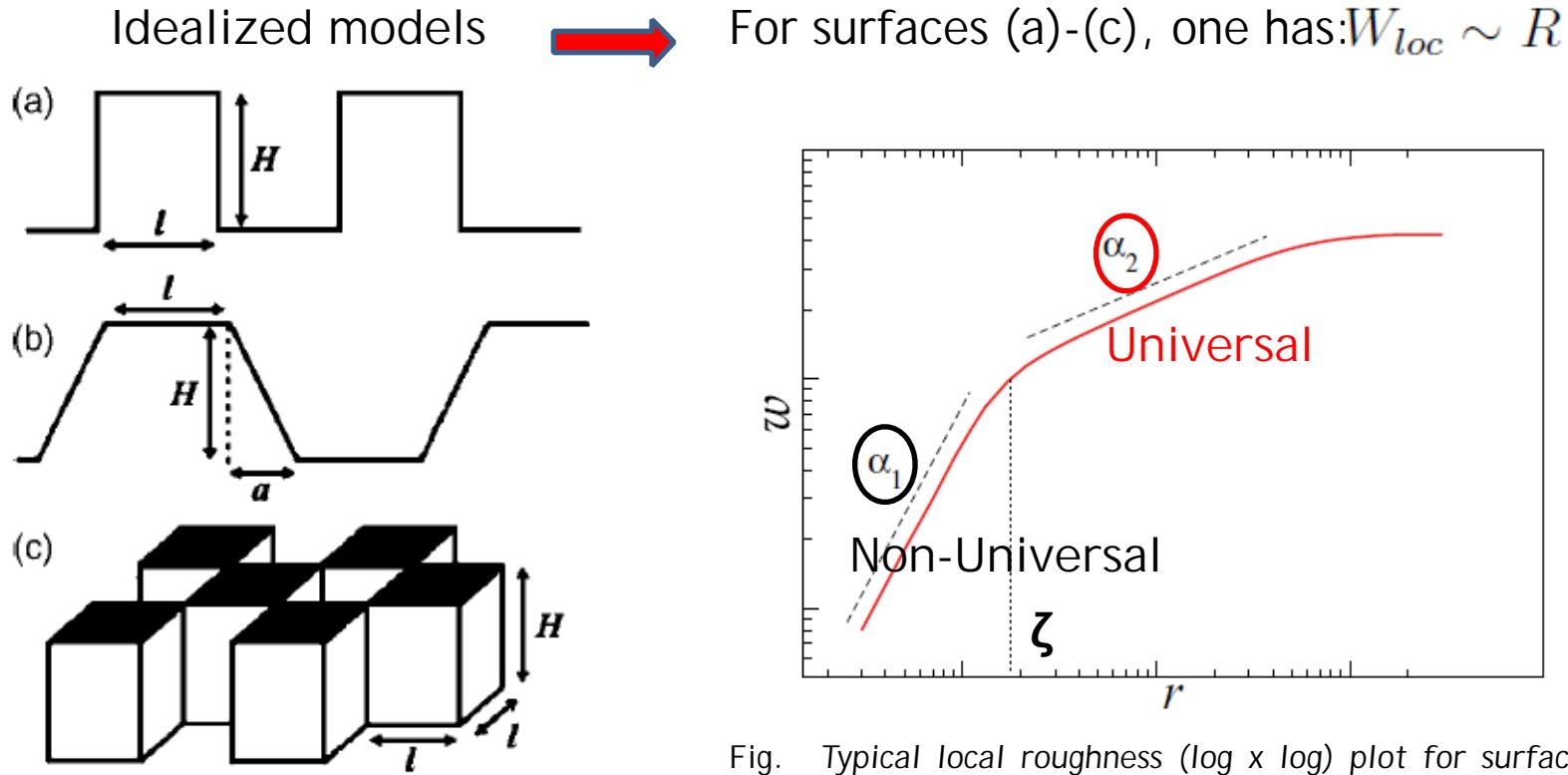
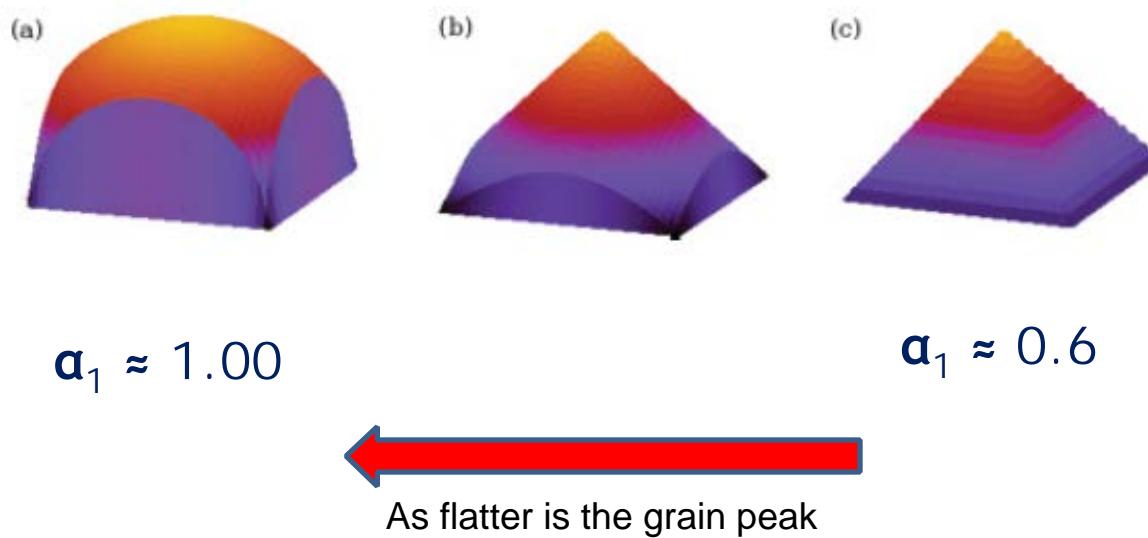


Fig. Typical local roughness ($\log \times \log$) plot for surfaces presenting a characteristic length ζ , beyond ξ and L .

Morphological instabilities at the surface

Geometric effect of the grain shape on the local scaling.



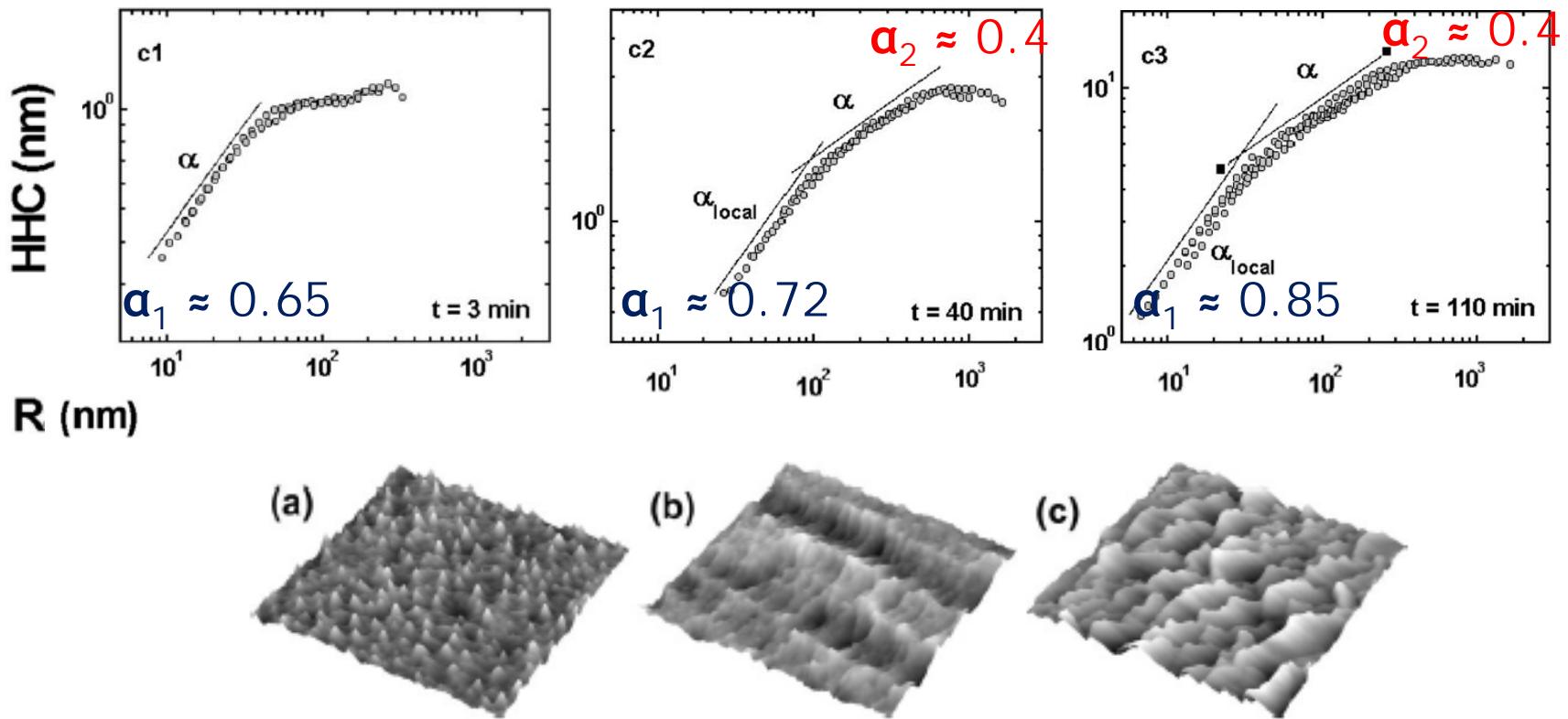
α_2 is kept constant, with your Universal value.

Morphological instabilities at the surface

Experimental evidences (2D KPZ?)

Si(111) etching by NaOH

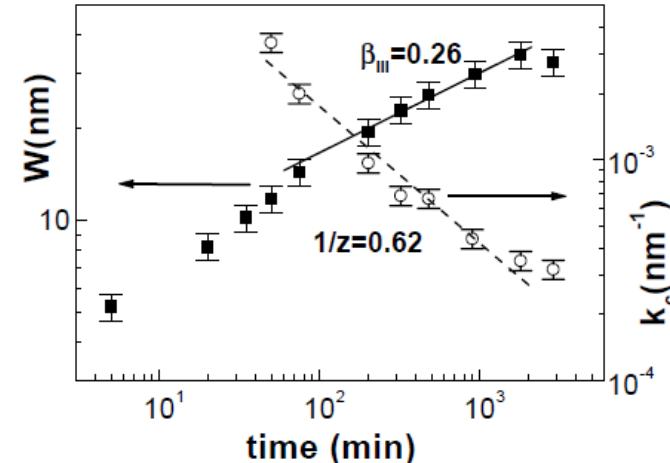
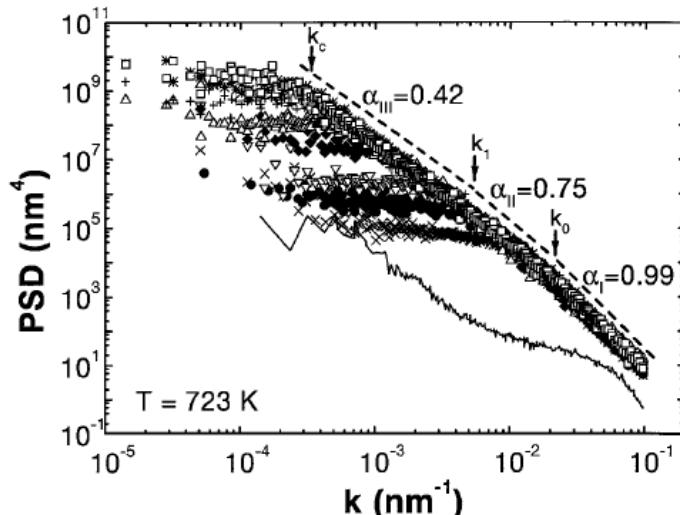
Likely to be a 2D KPZ growth!



2D-KPZ Growth: Why are they experimentally rare?

- Specific obstacles depending on what system is considered:
 - Morphological instabilities
 - * Temporal Crossovers
- Transient Anomalous Scaling (as we shall see)
- Non-locality **Dimensional fragility** of KPZ equation
M. Nicoli *et al.*, *J. of Stat. Mech.* **1**, 11001 (2013).

SiO₂ grown on Si(001) by CVD



Again, α_2 just was noted after long times, where $\xi \gg \zeta$.

Presents temporal crossover

2D-KPZ Growth: are they really rare?

List of other 2D experimental systems which, possibly, belong to the KPZ class:

1 - J. Chevrier *et al.*, EPL **16**, 737 (1991). **Fe/Si(111) by MBE**

2 - E. A. Eklund *et al.*, PRL **67**, 1759 (1991). **Sputter etching on graphite**

3 - M. U. Klinke *et al.*, Appl. Phys. Lett **74**, 1683 (1999). **Annealed LiCoO_x films**

4 - A. E. Lita *et al.*, Phys. Rev. B **61**, 7692 (2000). **Sputter-deposited polycrystalline Al films**

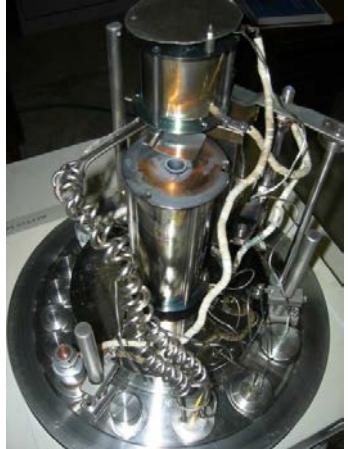
5 - M. E. R. Dotto and, M. U. Klinke, Phys. Rev. B **65**, 245323 (2002). **Etching on Si**

6 - S. O. Ferreira *et al.*, Appl. Phys. Lett. **88**, 244102 (2006). **CdTe grown on glass by HWE**

and the list goes
further ...

The First Robust Experimental Confirmation of 2D-KPZ Growth

R. A. L. Almeida, S. O. Ferreira, T. J. Oliveira, F. D. A. A. Reis, Phys. Rev. B. 89, 045309 (2014)



HWE system

$\Phi \approx 2.2 \text{ \AA/s}$ $T = 250^\circ\text{C}$

Growth times: 15, 30... 240 min.



AFM NT-MDT NTegra Prima

Contact mode

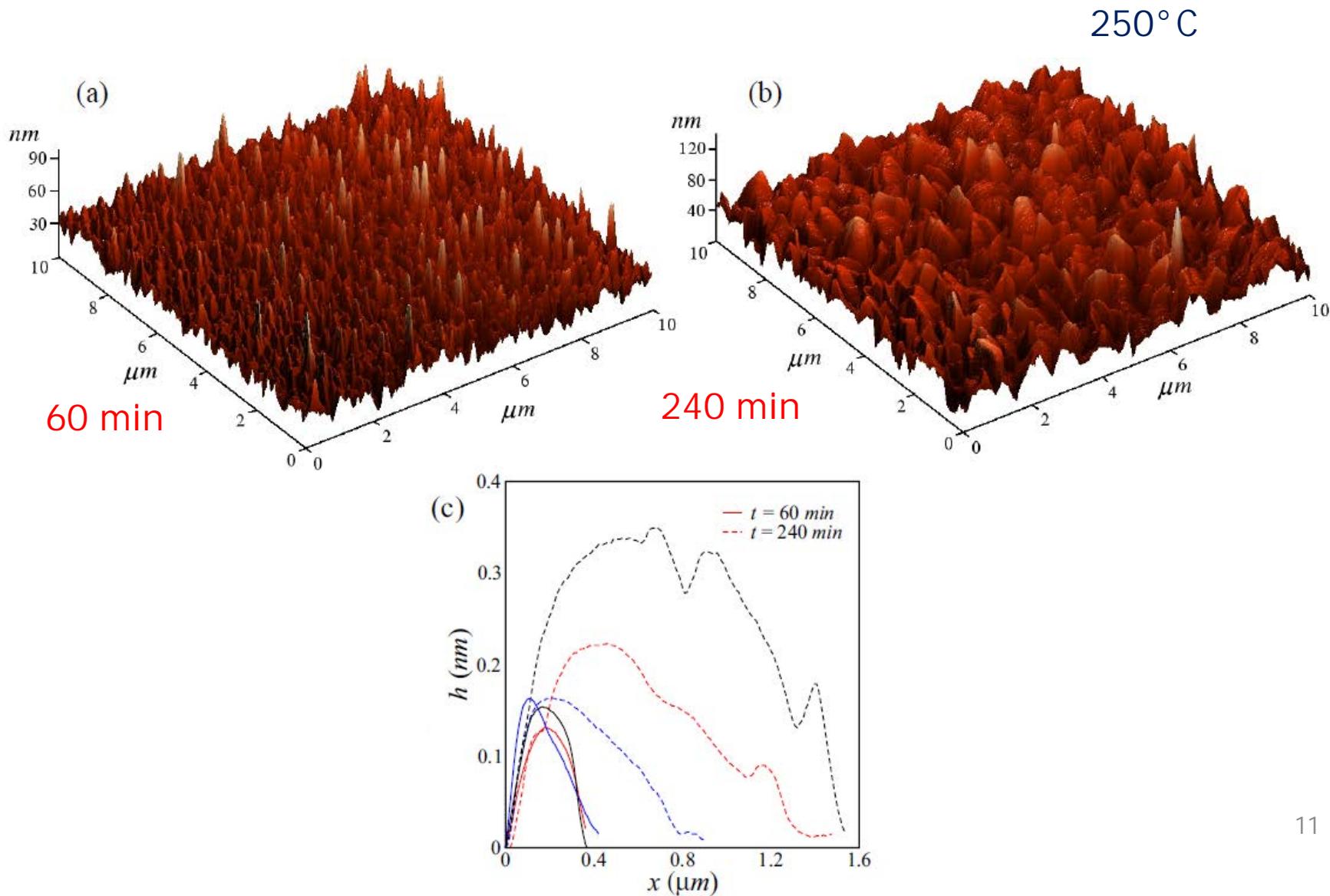
Images size: 1, 10 and 100 μm^2

Resolution: 1024 x 1024 pixel

N. of scanned regions : 3 - 10

The First Robust Experimental Confirmation of 2D-KPZ Growth

R. A. L. Almeida, S. O. Ferreira, T. J. Oliveira, F. D. A. A. Reis, Phys. Rev. B. 89, 045309 (2014)

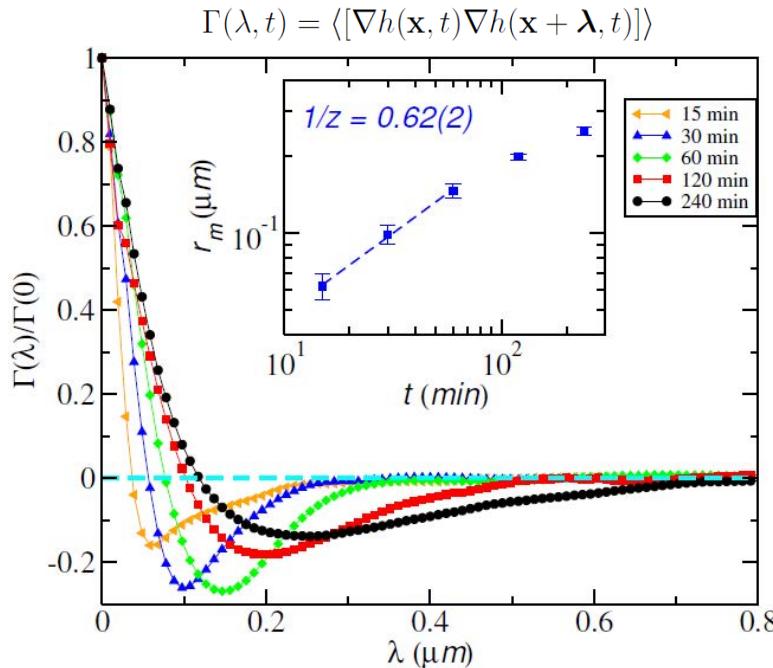


The First Robust Experimental Confirmation of 2D-KPZ Growth

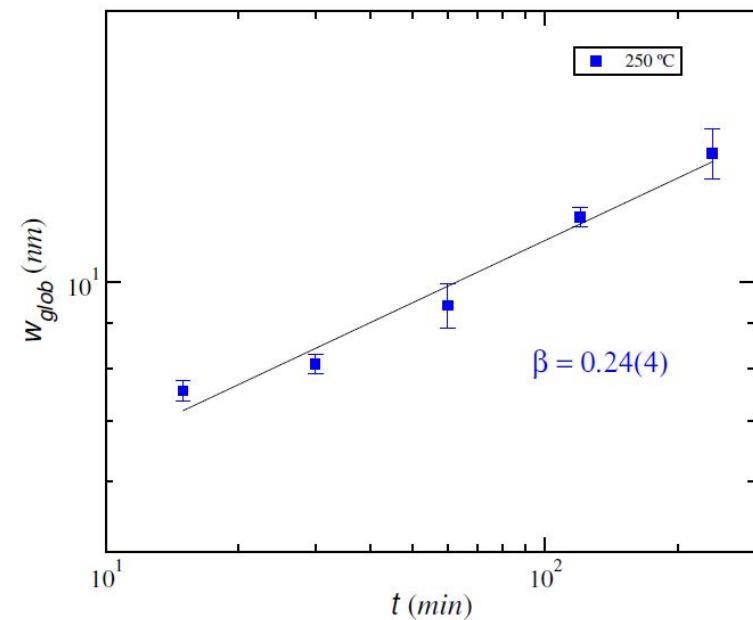
R. A. L. Almeida, S. O. Ferreira, T. J. Oliveira, F. D. A. A. Reis, Phys. Rev. B. 89, 045309 (2014)

- Grains and coalescence processes modify the local scaling and, hence, the analysis of local quantities which must be made carefully.

Slope-Slope corr. function



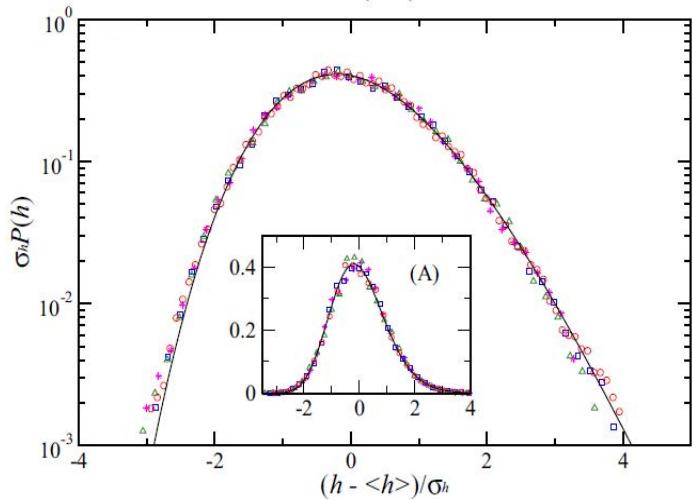
Global roughness



Best estimatives for the 2D KPZ exponents: $\beta = 0.241(1)$; $\alpha = 0.393(3)$; $1/z = 0.61(1)$
T. Halpin-Healy, PRE, **88** 042118 (2013).
J. Kelling and G. Ódor, PRE, **84** 061150 (2011).

The First Robust Experimental Confirmation of 2D-KPZ Growth

R. A. L. Almeida, S. O. Ferreira, T. J. Oliveira, F. D. A. A. Reis, Phys. Rev. B. 89, 045309 (2014)



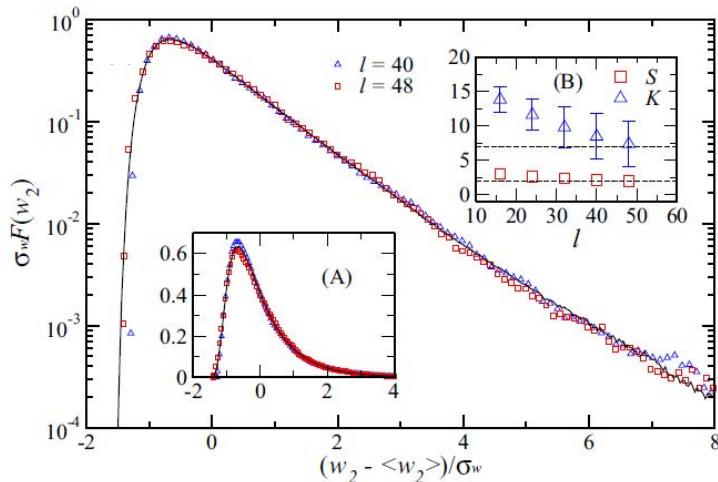
2D TW-GOE counterpart

$S = 0.34(4)$ and $K = 0.3(1)$

Asymptotic values: $S_{\text{KPZ}} = 0.42(2)$ and $K_{\text{KPZ}} = 0.34(2)$

T. Halpin-Healy, PRL **109**, 170602 (2012).

T. J. Oliveira, S. G. Alves, and S. C. Ferreira , PRE **87**, 040102(R) (2013).



Signature of Universal 2D-KPZ growth:
“The stretched exponential decal in the right tail ”

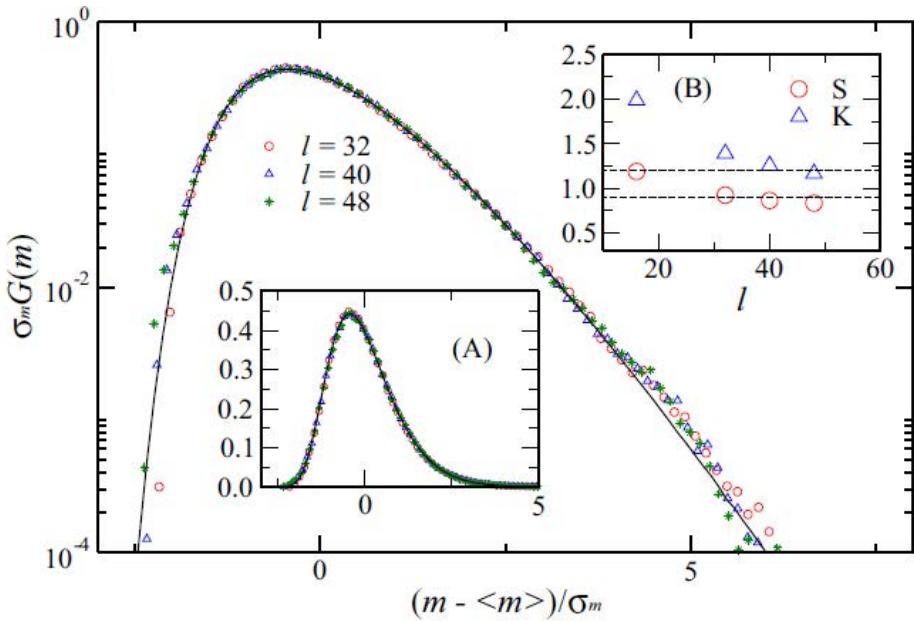
F. D. A. A. Reis, PRE E, **72** 032601 (2005).

T. Paiva and, F. D. A. A. Reis, Surf. Sci. **601**, 419 (2007).

T. Halpin-Healy *et al.*, EPL **105**, 50001 (2014).

The First Robust Experimental Confirmation of 2D-KPZ Growth

R. A. L. Almeida, S. O. Ferreira, T. J. Oliveira, F. D. A. A. Reis, Phys. Rev. B. 89, 045309 (2014)



Universal Extremal Height Distributions
for 2D-KPZ surfaces at the growth regime

T. J. Oliveira and, F. D. A. A. Reis, PRE, 77 041605 (2008).

T. Halpin-Healy *et al.*, EPL 105, 50001 (2014).

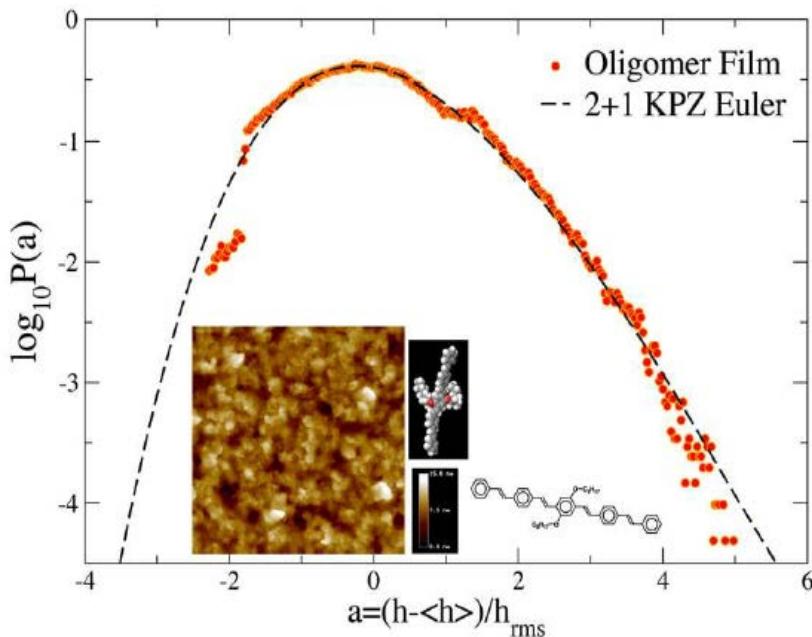


Link to Extremal value statistics

S. Raychaudhuri *et al.* Phys. Rev. Lett., 87, 136101 (2001).
D. -S Lee, Phys. Rev. Lett., 95, 150601 (2005).

2D-KPZ Universality in Oligomer Films

"Motivated by (...) an experimental work on semiconductor films (...)"



An very important 2D-experimental confirmation [the first one]

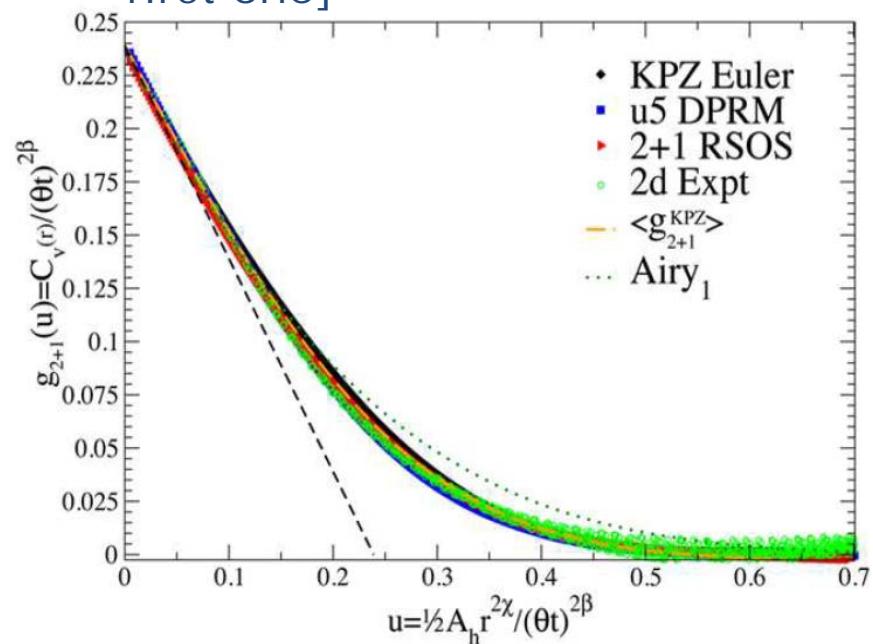


Fig. (Left): Universal 2D-KPZ height distribution in oligomer films. (Right) Rescaled spatial covariance for theoretical predictions and experimental realizations. Both agree with the 2D Airy1 process counterpart.

"(...) one sees the beginning of a new era in higher-dimensional KPZ experimental work."

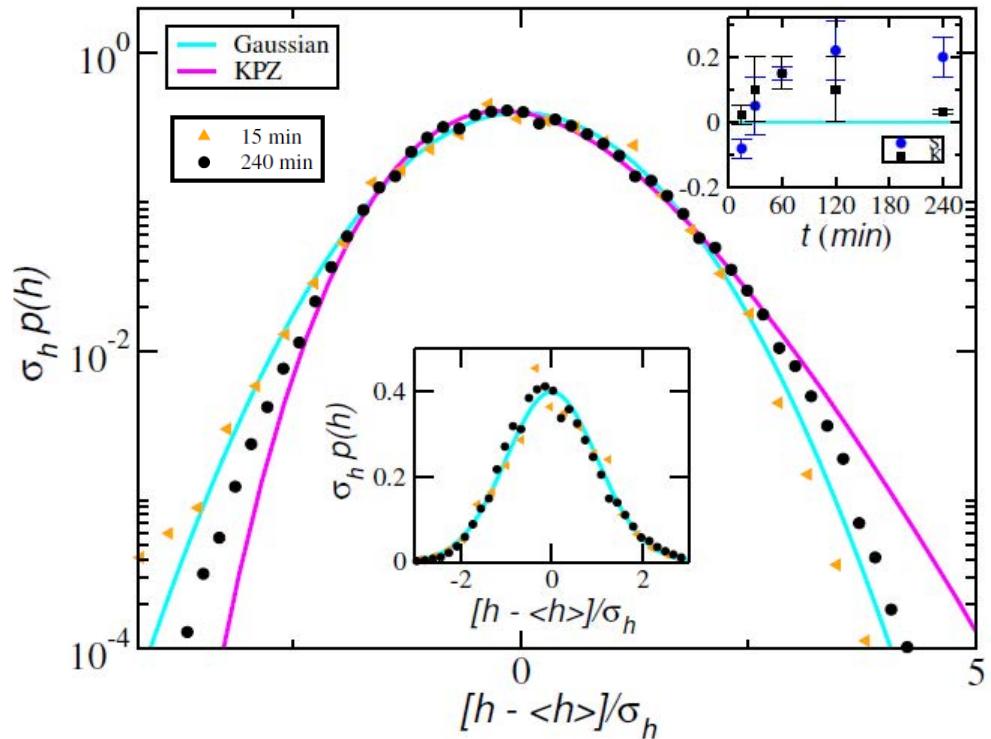
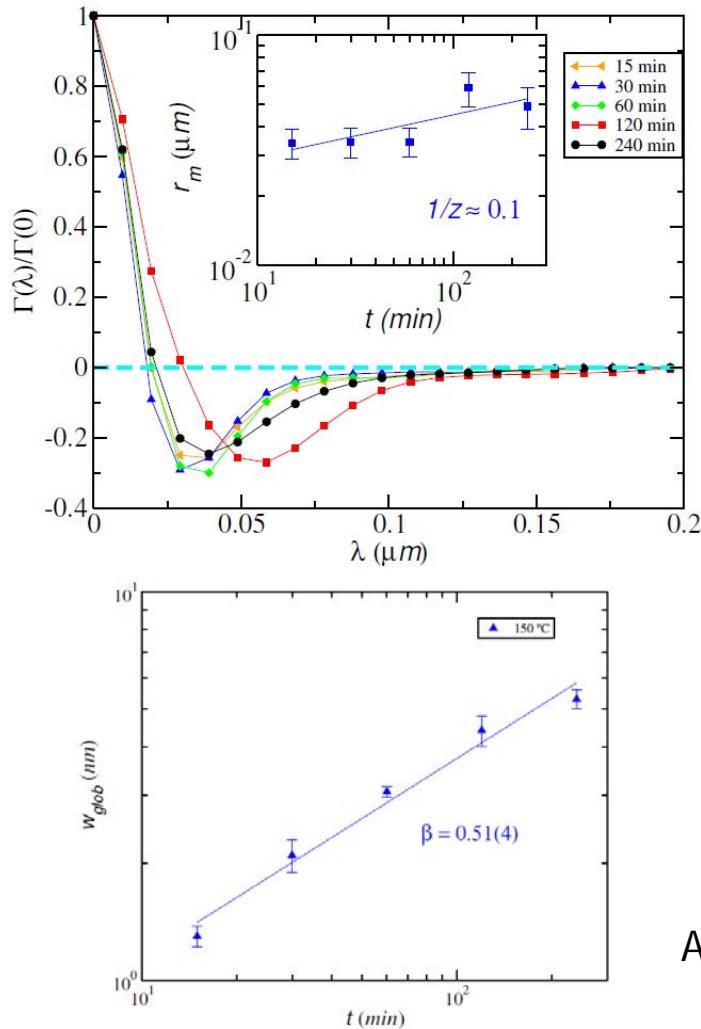
T. Halpin-Healy *et al.*, *EPL* **105**, 50001 (2014).

Changing the deposition temperature in the CdTe/Si(001) 2D-KPZ system

R. A. L. Almeida, S. O. Ferreira, I. R. B. Ribeiro and, T. J. Oliveira – To be submitted.

Samples grown at 150°C

- The smallest deposition temperature



Consistent with 2D- POISSON PROCESS

$$\mathbf{v} = 0 \text{ and } \boldsymbol{\lambda} = 0$$

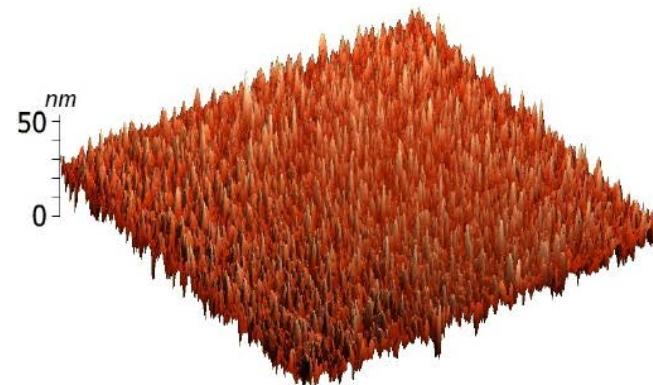
At this range of time, noise dominates the growth

Changing the deposition temperature in the CdTe/Si(001) 2D-KPZ system

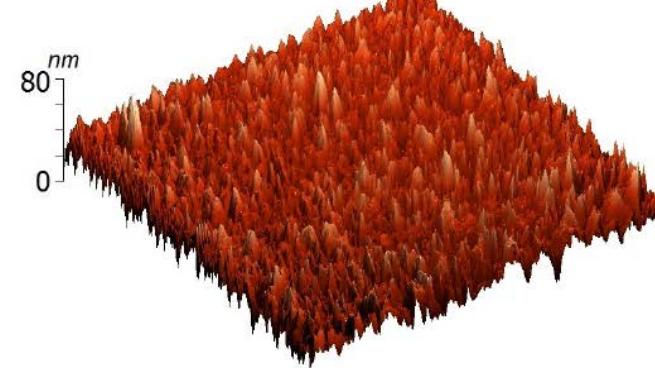
R. A. L. Almeida, S. O. Ferreira, I. R. B. Ribeiro and, T. J. Oliveira – To be submitted.

Samples grown at 200°C

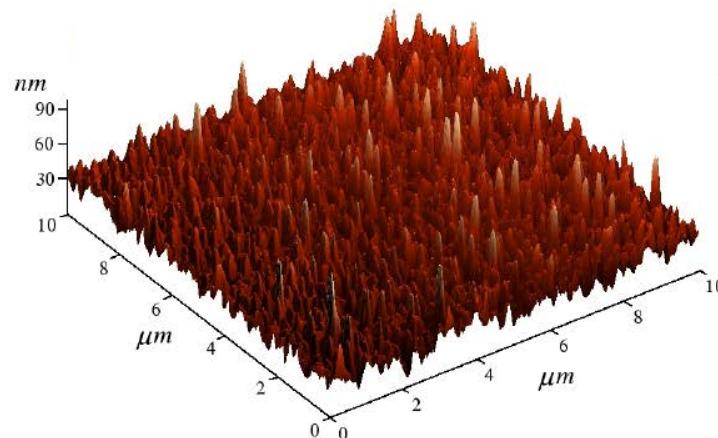
- Increasing the temperature: morphological analysis.



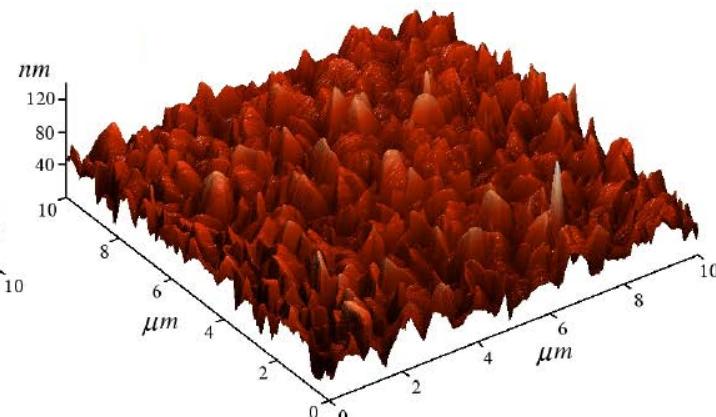
60 min



240 min



200°C



250°C

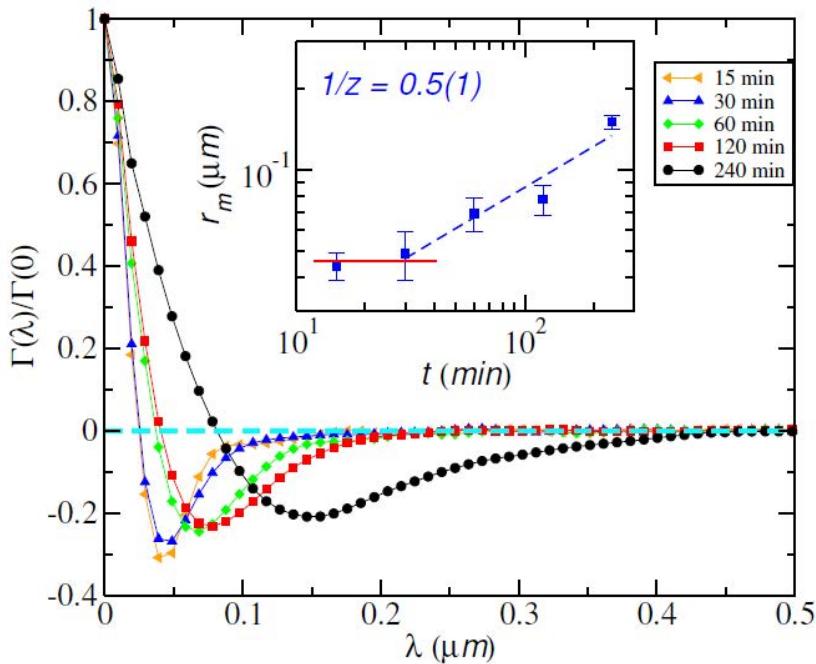
Changing the deposition temperature in the CdTe/Si(001) 2D-KPZ system

R. A. L. Almeida, S. O. Ferreira, I. R. B. Ribeiro and, T. J. Oliveira – To be submitted.

Samples grown at 200°C

2 - Local Scaling analysis.

$$\langle (\nabla h)^2 \rangle \sim t^{2\kappa} \quad \text{Lópes, J. M., PRL } \mathbf{83}, 4594 \text{ (1999).}$$



It suggests: $1/Z_{EW} = 0.50$ or $1/Z_{KPZ} \approx 0.61$

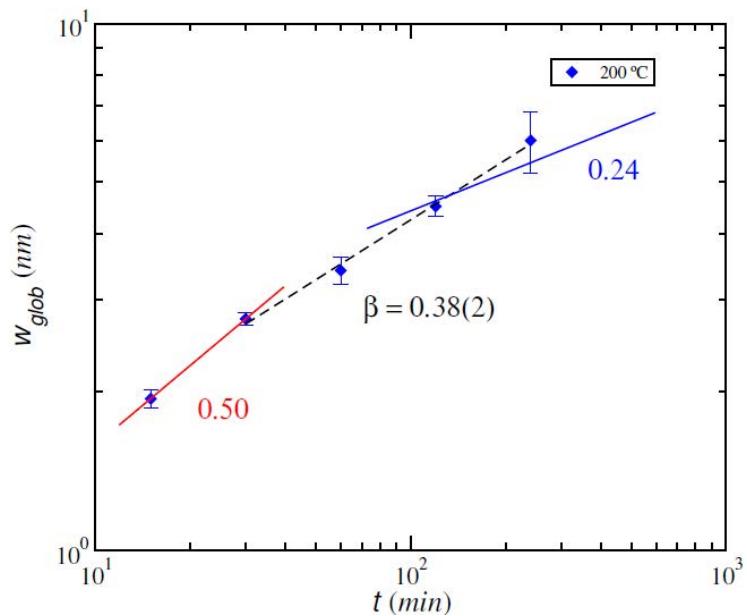
Transient Anomalous Scaling and asymptotic FV Scaling

Changing the deposition temperature in the CdTe/Si(001) 2D-KPZ system

R. A. L. Almeida, S. O. Ferreira, I. R. B. Ribeiro and, T. J. Oliveira – To be submitted.

Samples grown at 200°C

3 - Global Analysis



Again, we have clues of a temporal crossover

β value is far away from the 2D-KPZ value

A crossover towards the KPZ regime ?

$$S = 0.43(5) \text{ and } K = 0.5(2)$$

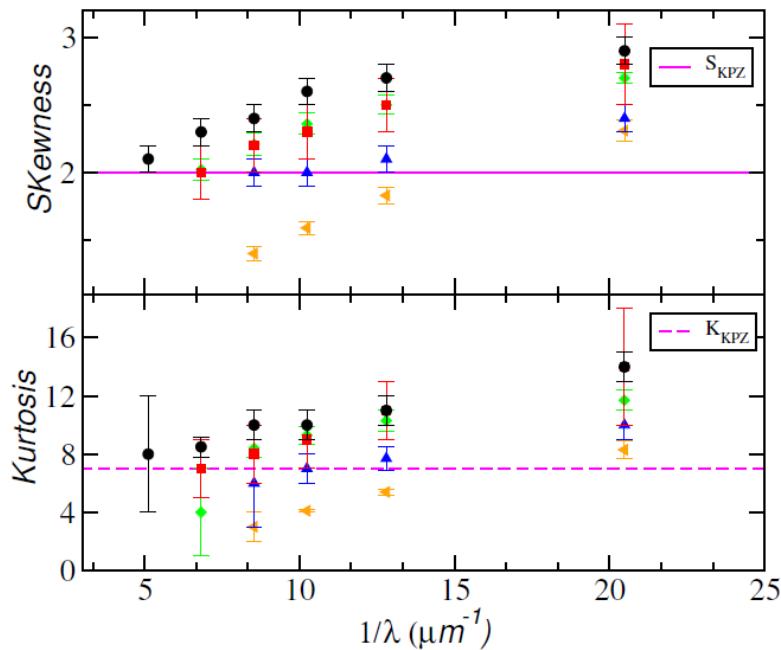
$$S_{KPZ} = 0.42(2) \text{ and } K_{KPZ} = 0.34(2)$$

Changing the deposition temperature in the CdTe/Si(001) 2D-KPZ system

R. A. L. Almeida, S. O. Ferreira, I. R. B. Ribeiro and, T. J. Oliveira – To be submitted.

Samples grown at 200°C

4 - Universal Local Distributions



Signature of 2D-KPZ: “Streched exponential rigth tails for fours decade around the peak” !!!

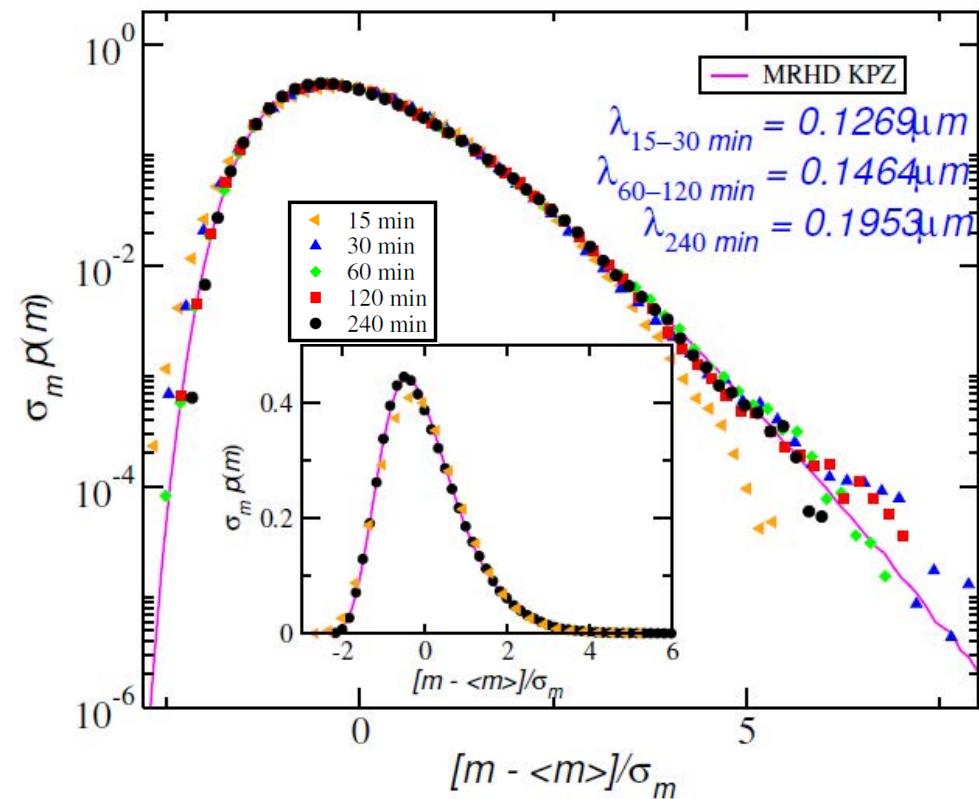
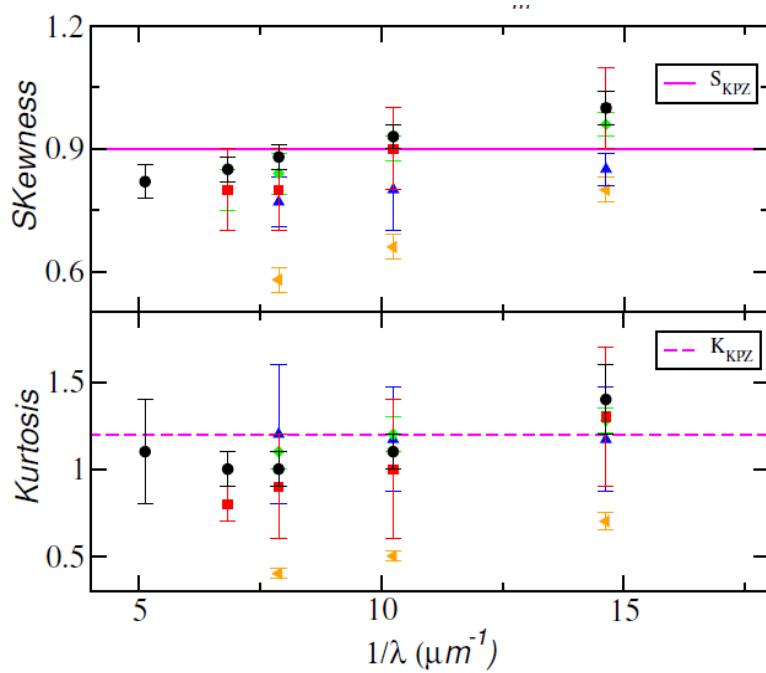
Fig. (Left) Skewness and Kurtosis as function of coarsening grained level. (Rigth) Squared Local Roughness Distribution (SLRD) for CdTe thin films compared with the Universal KPZ SLRD.

Changing the deposition temperature in the CdTe/Si(001) 2D-KPZ system

R. A. L. Almeida, S. O. Ferreira, I. R. B. Ribeiro and, T. J. Oliveira – To be submitted.

Samples grown at 200 °C

4 - Universal Local Distributions



MRHD is not so accurate as SLRD, but it also indicates 2D-KPZ growth
!!!

Fig. (Left) Skewness and Kurtosis as function of coarsening grained level. (Righ) Squared Local Roughness Distribution (MRHD) for CdTe thin films compared with the Universal KPZ MRHD. ²¹

Changing the deposition temperature in the CdTe/Si(001) 2D-KPZ system

R. A. L. Almeida, S. O. Ferreira, I. R. B. Ribeiro and, T. J. Oliveira – To be submitted.

Samples grown at 200°C

4 – Partial Conclusions

- The $1/z$ exponent agrees with the 2D-KPZ value.
- A transient Anomalous Scaling occurs for initial growth times.
- The universal roughness exponent can not be measured directly by the local roughness curve.
- Growth exponent does not agree with any UC known due to a possible temporal crossover.



GROWTH EXPONENT, in these circumstances, “FAIL” for predicting the UC of the growth.

- GLOBAL AND LOCAL DISTRIBUTIONS provide a strong evidence of Random-to-KPZ CROSSOVER.

IN THIS CASE, THE UC WOULD NOT BE ACHIEVED WITHOUT THE DISTRIBUTION ANALYSIS

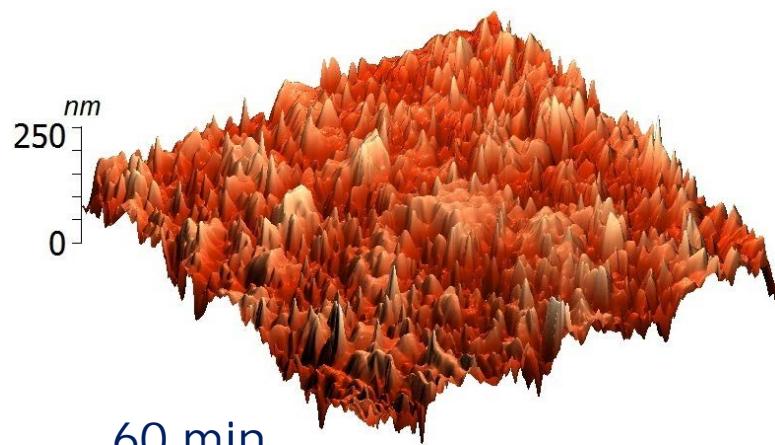
Changing the deposition temperature in the CdTe/Si(001) 2D-KPZ system

R. A. L. Almeida, S. O. Ferreira, I. R. B. Ribeiro and, T. J. Oliveira – To be submitted.

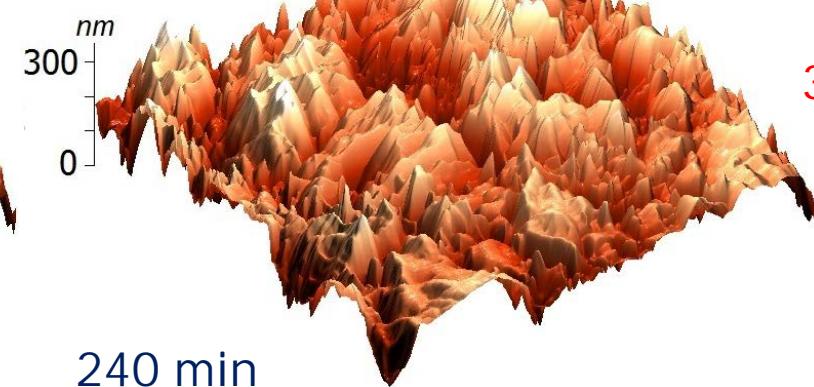
Samples grown at 300°C

- Higher deposition Temperature

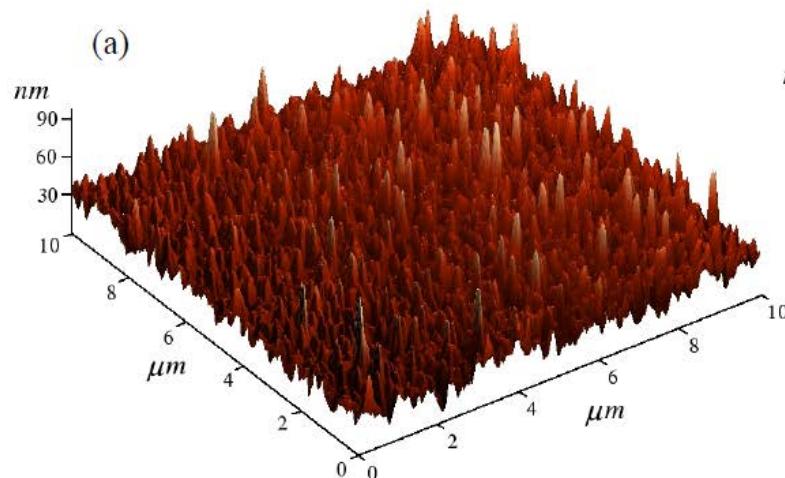
Coalescence since early growth times => the procedure for measuring $1/z$ becomes unappropriate



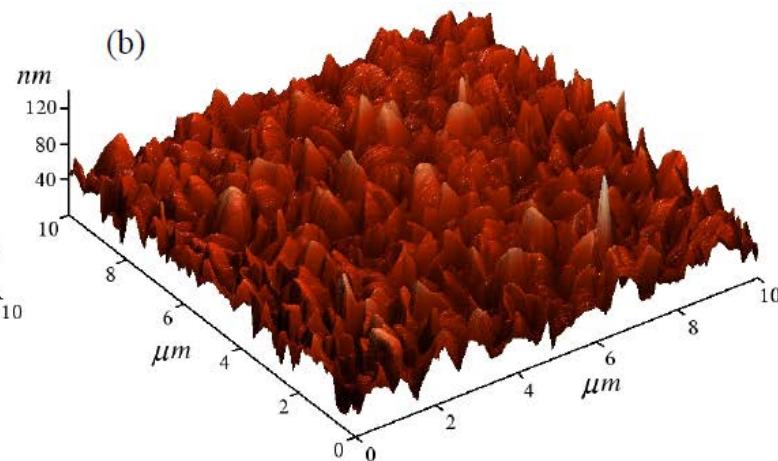
60 min



240 min



(a)



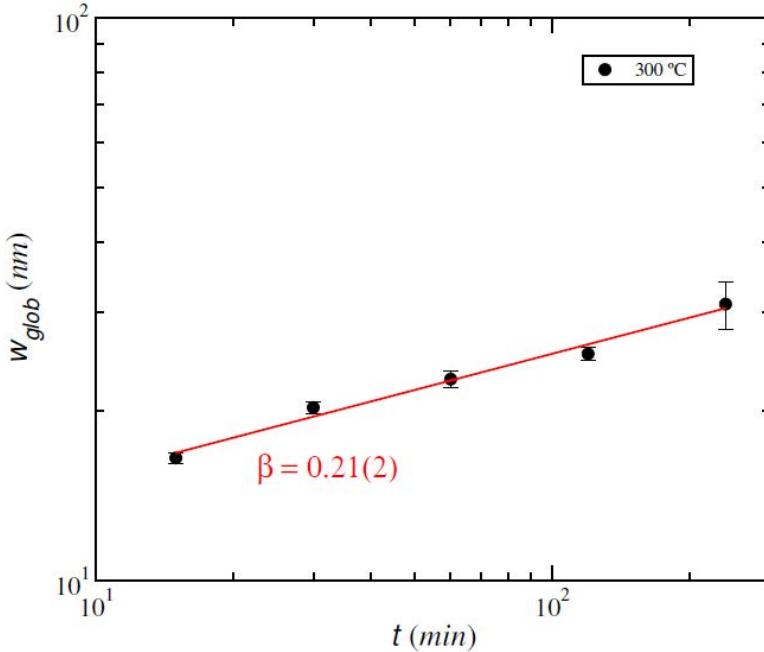
250°C

Changing the deposition temperature in the CdTe/Si(001) 2D-KPZ system

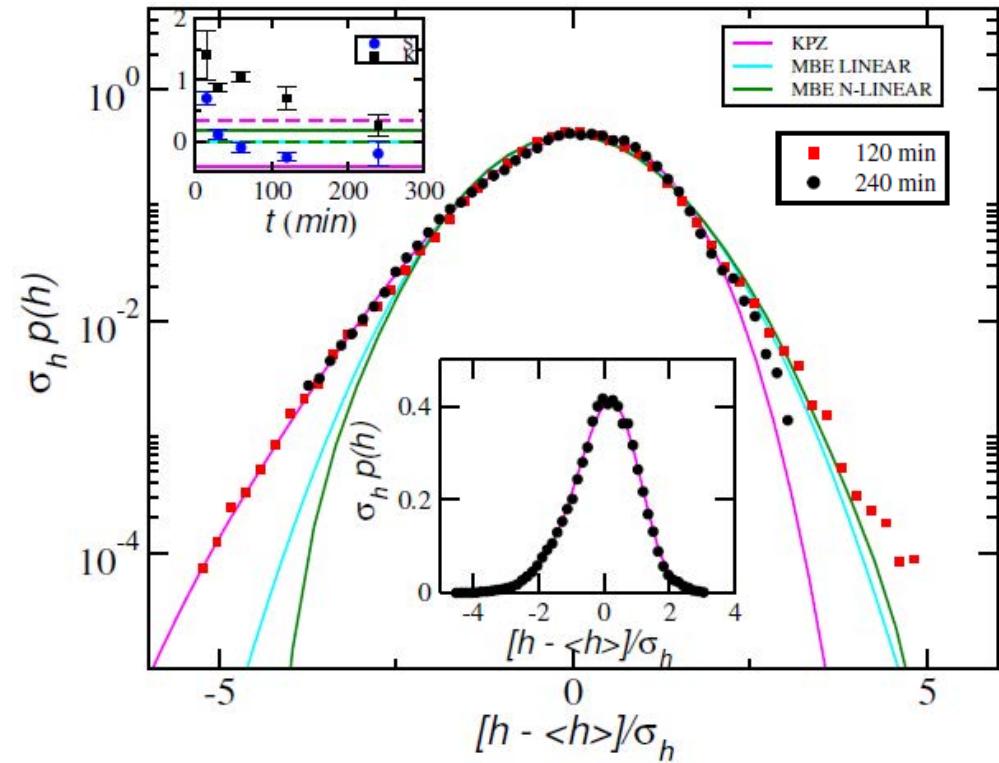
R. A. L. Almeida, S. O. Ferreira, I. R. B. Ribeiro and, T. J. Oliveira – To be submitted.

Samples grown at 300 °C

- Higher deposition Temperature



$$\beta = 0.21(2)$$



These values are close to $\beta_{\text{MBE(linear)}} = 0.25$, $\beta_{\text{MBE(N-linear)}} \approx 0.20$, and $\beta_{\text{KPZ}} \approx 0.24$

HDS approach to the 2D-KPZ one with negative skewness [It seems to discard MBE growth]

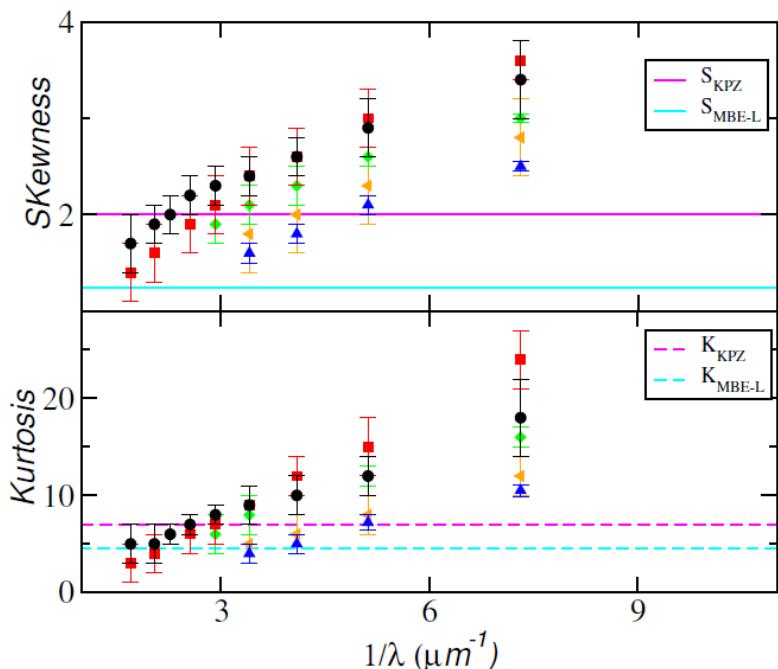
However, at this point, we can not assure the Universality Class

Changing the deposition temperature in the CdTe/Si(001) 2D-KPZ system

R. A. L. Almeida, S. O. Ferreira, I. R. B. Ribeiro and, T. J. Oliveira – To be submitted.

Samples grown at 300°C

- Higher deposition Temperature



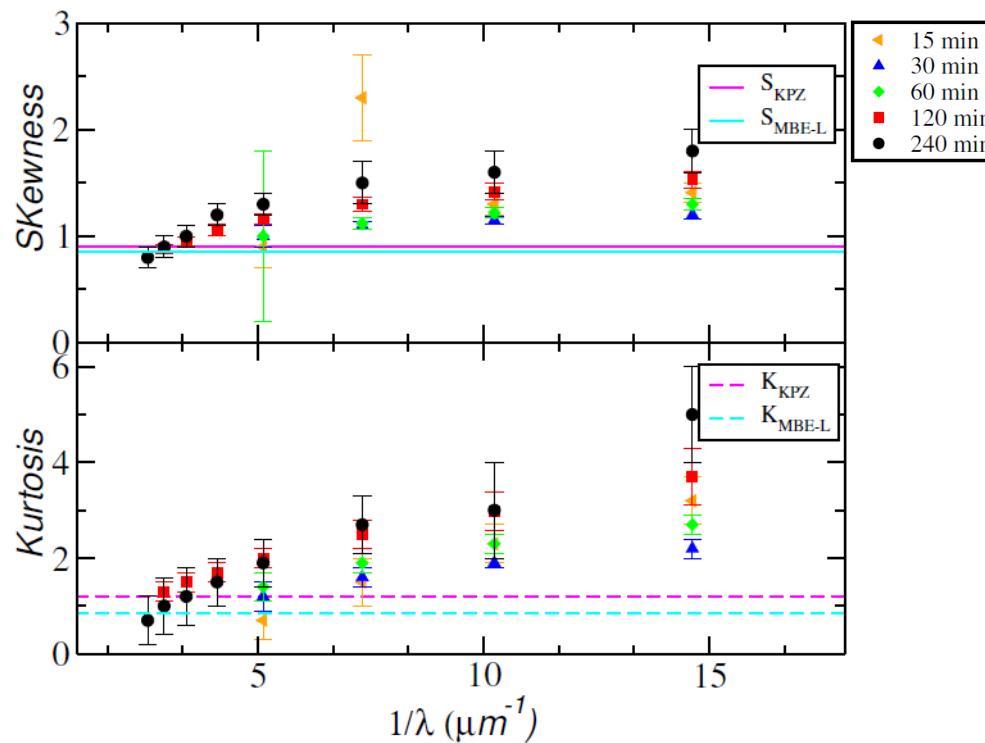
Once again, SLRDs offer the most reliable way for accessing UC of a growth. One finds the 2D-KPZ growth.

Changing the deposition temperature in the CdTe/Si(001) 2D-KPZ system

R. A. L. Almeida, S. O. Ferreira, I. R. B. Ribeiro and, T. J. Oliveira – To be submitted.

Samples grown at 300°C

- Higher deposition Temperature



MRHD's can not provide us a distinction between MBE-L and KPZ ...

Changing the deposition temperature in the CdTe/Si(001) 2D-KPZ system

R. A. L. Almeida, S. O. Ferreira, I. R. B. Ribeiro and, T. J. Oliveira – To be submitted.

■ Higher deposition Temperature: Partial Conclusions

- The procedure for measuring the $1/z$ exponent is unappropriate, once coalescence processes occur since early growth times.
- It is not possible to unearth the global exponent using the local roughness curve.
- Growth exponent provide a value close of the KPZ and MBE classes.



HDs show a negative skewness agreeing with the S. and K. KPZ values

SLRDS also indicate a 2D-KPZ growth

Changing the deposition temperature in the CdTe/Si(001) 2D-KPZ system

R. A. L. Almeida, S. O. Ferreira, I. R. B. Ribeiro and, T. J. Oliveira – To be submitted.

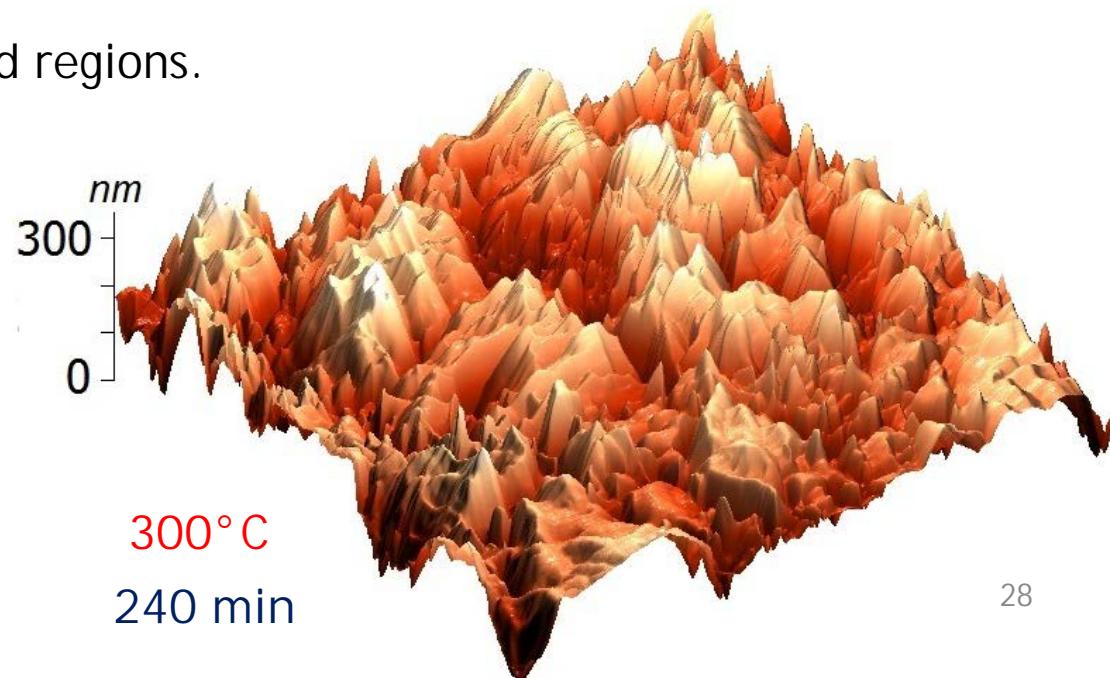
- Higher deposition Temperature: Partial Conclusions

Assuming KPZ growth even at higher temperatures, what is the POSSIBLE KPZ mechanism?

Local inclinations are, at least, 5x bigger than samples grown at 250 °C.

Particles refused at inclined regions.
(small sticking coef. ?)

Origin of large mounds and extended-defect-lines



Conclusions and Perspectives

- 2D-KPZ growth is found in CdTe/Si(001) thin films at a large range of deposition temperature.
 - At the smallest T, exponents and HDs are consistent with **Poisson Process**.
 - For $T = 200^\circ\text{C}$, **GROWTH EXPONENT "FAIL"** due to a finite-time growth and the Random-to-KPZ crossover, indicated by **DISTRIBUTIONS**. A transient Anomalous Scaling is found.
 - For $T = 300^\circ\text{C}$, exponents do not help us to decide between KPZ and MBE classes. Universal distributions point out KPZ growth, however, with negative λ .

THE UC OF 2D-GROWTH IS HARDLY ACCESSED ONLY THROUGH THE ESTIMATE OF SCALING EXPONENTS. THE ANALYSIS OF DISTRIBUTIONS ARE ESSENTIALS IN THIS CONTEXT.

Strong reason why so many works have been reporting several exponents with no association with an UC

Conclusions and Perspectives

- Using the same system grown at different conditions (which provide the KPZ regime since early growth times) we'll focus in to validate the KPZ $\ddot{\text{a}}\text{n}\dot{\text{s}}\dot{\text{a}}\text{t}\dot{\text{z}}\text{e}$ in two-dimensional growth, as well the spatial covariance (in the presence of grains).

R. A. L. Almeida, I. S. S. Carrasco et al. [in progress]



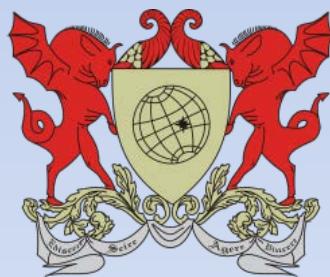
Ph.D. S. O.
Ferreira
Mentor



R. A. L. Almeida
(Magister
Student)



D. Sc. T. J.
Oliveira
Mentor



UNIVERSIDADE
FEDERAL DE VIÇOSA



D. Sc. F. D. A. A.
Reis
Co-Worker





本当にありがとうございました



Muito obrigado!



UNIVERSIDADE
FEDERAL DE VIÇOSA



Renan A. L. Almeida

e-mail: renan.lisboa@ufv.br

Master Student at Universidade Federal de Viçosa,
Minas Gerais, Brasil